

Structure Refinement of the Semiconducting Compound Cu₃TaS₄ from X-Ray Powder Diffraction Data*

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The ternary compound Cu₃TaS₄ has been investigated by means of X-ray powder diffraction and its structure has been refined by the Rietveld method. This compound is isostructural with the sulvanite mineral Cu₃VS₄, and crystallizes in the cubic $P\bar{4}3m$ space group (No. 215), $Z = 1$, with unit cell parameters $a = 5.5145(1)$ Å and $V = 167.70(1)$ Å³. The refinement of 14 instrumental and structural parameters converged to $R_p = 4.4\%$, $R_{wp} = 6.8\%$, $R_{exp} = 5.5\%$ and $S = 1.2$ for 4501 step intensities and 33 independent reflections.

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1. Introduction

Ternary compounds belonging to the family Cu₃-M-VI₄ (M = V, Nb, Ta, VI = S, Se, Te) are interesting materials due principally to their potential applications as electronic devices, especially as light-modulators [1, 2]. Earlier studies on the lattice vibration in the sulfide and selenide compounds revealed that they belong to the *p*-type semiconductors [3–5]. More recently, the calculated electronic structure of the sulvanite compounds Cu₃TMS₄ (TM = V, Nb, Ta), indicated that they are semiconductors with indirect band gap and the analysis of the electron localization function (ELF) reveals the ionic character of these semiconductors materials [6]. Another work shows that the Cu₃TaS₄-Cu₃TaSe₄ system exhibits excellent optoelectronic properties as *p*-type conductivity, large optical band gap energy, and tunable visible photoemission [7]. The optical band gap energy of the sulfide ($E_g = 2.70$ eV) make Cu₃TaS₄ transparent to most visible light, and thin films of this material could be used in transparent electronics as *p*-type layers in active devices including *p-n* junctions, transistor channel layers, and photovoltaics [7].

From the crystallographic point of view, several authors have reported the preparation of this type of ma-

terials and have associated their structures with that of the mineral sulvanite, which crystallizes with cubic symmetry $P\bar{4}3m$ [8, 9], and therefore are expected to show isotropic electrical and optical properties. The crystal structures of Cu₃VS₄ [9], Cu₃NbS₄ [10], Cu₃VSe₄ [11], Cu₃NbSe₄ [12], Cu₃TaSe₄ [13], Cu₃NbTe₄ [14] and Cu₃TaTe₄ [15] have been previously established by means of X-ray diffractometry. For Cu₃VTe₄ there is no structural data. In contrast, for Cu₃TaS₄ only an early study, using X-ray cameras, was found in the ICSD database [16]. The report, without a crystal structure characterization or *R* value given in the paper, describes this material as an undistorted sulvanite structure (ICSD #53335) [16]. In this work, we report the structure of the ternary compound Cu₃TaS₄ determined from X-ray powder diffraction data using the Rietveld refinement. Structural analyses of the completed Cu₃-M-VI₄ (M = V, Nb, Ta, VI = S, Se, Te) system are also presented.

2. Experimental

The sample was synthesized using the melt and annealing technique. Stoichiometric quantities of Cu, Ta and S elements with purity of 99.9% were charged in an evacuated quartz ampoule, which was previously subjected to pyrolysis in order to avoid reaction of the starting materials with quartz. Then, the ampoule was sealed under vacuum and the fusion process was carried out inside a furnace (vertical position) heated up to 1500 °C at a rate of 20 °C/h, with a stop of 48 h at 150 °C (melting temperature of S). The ampoule was shaken using a mechanical system during all the heating process in order to guarantee the complete mixing of all the elements. Then, the

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temperature was gradually raised at the same rate up to 850 °C. The ampoule was kept at this temperature for a period of 30 days. Finally, the sample was cooled to room temperature at a rate of 10 °C/h.

Chemical composition of the ingots was determined at several points by energy dispersive X-ray (EDX) analysis using a KeveX Model Delta-3 system connected to a Hitachi Model S-2500 scanning electron microscope (SEM). The average chemical composition of the central part of the ingot, from which the crystals were cut, gave the atomic percentage of Cu (37.4%), Ta (12.2%) and S (50.4%), close to the ideal value 3:0.98:4.04. The error in standardless analysis was around 5%.

For the X-ray analysis, a small quantity of the ingot obtained previously, was ground mechanically in an agate mortar and pestle. The resulting fine powder was mounted on a zero-background holder covered with a thin layer of petroleum jelly. The X-ray powder diffraction data were collected at 298(1) K, in a Philips PW-1250 diffractometer equipped with an X-ray tube (Cu K_α radiation: $\lambda = 1.54056$ Å; 40 kV, 25 mA), a diffracted beam graphite monochromator and a scintillation detector. The specimen was scanned from 10–100°(2 θ), in steps of 0.02° and counting time of 50 s/step. Silicon was used as an external standard.

3. Results and discussion

The X-ray diffractogram of Cu_3TaS_4 shows a single phase. The measured reflections were completely indexed in a cubic cell by using the program Dicvol04 [17]. As expected, this material is isostructural with the mineral sylvanite Cu_3VS_4 , which crystallizes in the space group $P\bar{4}3m$ (No. 215). The entire powder diffraction dataset of Cu_3TaS_4 was reviewed by means of the NBS*AIDS program [18] with the following results: $a = 5.5149(1)$ Å, $V = 167.73(1)$ Å³, and figures of merit $M_{20} = 340.6$ [19] and $F_{26} = 190.3$ (0.0053, 26) [20]. X-ray powder diffraction data of Cu_3TaS_4 are given in Table I.

The Rietveld refinement [21] of the Cu_3TaS_4 structure was carried out using the Fullprof program [22]. Initial positional parameters were taken from those of Cu_3TaSe_4 [13] and unit cell parameters were those yielded by the NBS*AIDS. The angular dependence of the peak full width at half maximum (FWHM) was described by Caglioti's formula. Peak shapes were described by the pseudo-Voigt profile function. The background variation was described by a polynomial with six coefficients. The thermal motion of the atoms was described by one overall isotropic temperature factor. The final figures of merit obtained when 14 above-listed instrumental and structural variables were refined, are summarized in Table II. The final Rietveld plot is shown in Fig. 1. Figure 2 shows the unit cell diagram of Cu_3TaS_4 . Unit cell parameters, atomic coordinates, isotropic temperature factor, bond distances and angles are shown in Table III.

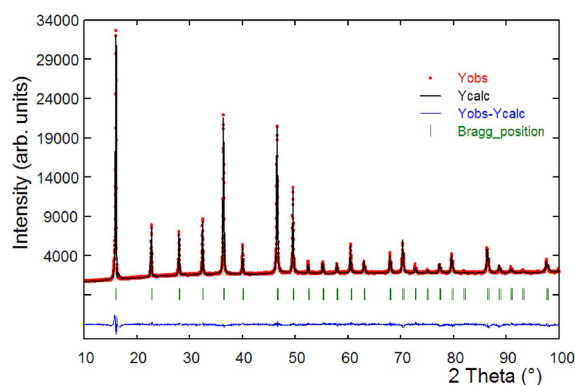


Fig. 1. Final Rietveld plot showing the observed, calculated and difference patterns of Cu_3TaS_4 .

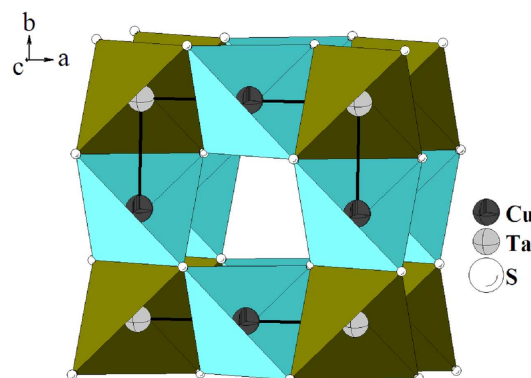


Fig. 2. Unit cell diagram of Cu_3TaS_4 show the stacking of the CuS_4 and TaS_4 tetrahedra.

This ternary compound crystallizes in a sylvanite-type structure, which consists of a three-dimensional arrangement of CuS_4 and TaS_4 tetrahedra connected by common edges. Figure 2 shows the unit cell diagram of Cu_3TaS_4 and the stacking of the tetrahedra which leaves a channel at the centre. The shortest S...S distance in this cavity is 3.900(4) Å.

The tetrahedra containing the Cu cations (mean value S–S distances 3.900(4) Å) are lightly larger than those containing the Ta atoms (mean S–S distance is 3.860(4) Å). All bond angles show minor deviations from the ideal tetrahedral values in a slightly distorted structure. The interatomic distances in the Cu_3TaS_4 structure (2.380 Å and 2.364 Å) are markedly shorter than the sum of their respective ionic radii (2.940 Å) [23].

A comparison of unit cell parameters and bond distances for the complete family $\text{Cu}_3\text{-M-VI}_4$ with M = V, Nb, Ta and VI = S, Se, Te is shown in Table IV. It is possible to observe that the parameters and the Cu–S and M–VI distances increase as changing M. This increase can be expected in view of the fact that the ionic radius of 0.36 Å for V^{5+} cations is greater than that of 0.48 Å for Nb^{5+} cations, and 0.64 Å for Ta^{5+} [23].

X-ray powder diffraction data of Cu₃TaS₄.

TABLE I

$2\theta_{\text{obs}}$ [°]	d_{obs} [Å]	$(I/I_0)_{\text{obs}}$	h	k	l	$2\theta_{\text{cal}}$ [°]	d_{cal} [Å]	$\Delta 2\theta$ [°]
16.062	5.5132	100.0	1	0	0	16.057	5.5149	-0.005
22.796	3.8976	24.2	1	1	0	22.784	3.8996	-0.012
28.005	3.1833	21.4	1	1	1	27.999	3.1840	-0.006
32.446	2.7570	26.5	2	0	0	32.441	2.7575	-0.005
36.403	2.4659	66.9	2	1	0	36.396	2.4663	-0.007
40.015	2.2512	16.2	2	1	1	40.011	2.2515	-0.004
46.553	1.9492	63.0	2	2	0	46.537	1.9498	-0.016
49.547	1.8382	38.6	3	0	0	49.543	1.8383	-0.004
52.424	1.7439	10.1	3	1	0	52.420	1.7440	-0.003
55.195	1.6627	9.9	3	1	1	55.190	1.6628	-0.005
57.872	1.5920	9.0	2	2	2	57.870	1.5920	-0.001
60.475	1.5295	16.7	3	2	0	60.474	1.5296	-0.001
63.009	1.4740	10.1	3	2	1	63.012	1.4739	0.003
67.924	1.3788	13.3	4	0	0	67.927	1.3787	0.003
70.319	1.3376	17.1	4	1	0	70.320	1.3376	0.001
72.681	1.2998	8.9	3	3	0	72.677	1.2999	-0.004
75.013	1.2651	6.8	3	3	1	75.005	1.2652	-0.008
77.305	1.2332	8.9	4	2	0	77.307	1.2332	0.002
79.587	1.2035	13.0	4	2	1	79.589	1.2035	0.001
81.845	1.1759	6.2	3	3	2	81.854	1.1758	0.009
86.343	1.1258	15.1	4	2	2	86.349	1.1257	0.006
88.583	1.1030	7.8	4	3	0	88.587	1.1030	0.004
90.826	1.0815	8.2	5	1	0	90.822	1.0816	-0.004
93.051	1.0614	6.5	5	1	1	93.059	1.0613	0.008
97.542	1.0242	10.7	5	2	0	97.550	1.0241	0.008
99.816	1.0068	7.1	5	2	1	99.812	1.0069	-0.004

Rietveld refinement details for Cu₃TaS₄.

TABLE II

molecular formula	Cu ₃ TaS ₄	data range 2θ [°]	10–100
molecular weight [g/mol]	499.9	step size 2θ [°]	0.02
a [Å]	6.9670(3)	counting time [s]	50
V [Å ³]	550.6(5)	No. step intensities	4501
Z	1	No. independent reflections	33
space group	$P\bar{4}3m$ (No. 215)	peak-shape profile	pseudo-Voigt
D_{calc} [g/cm ⁻³]	4.95	λ	Cu $K\alpha$ (1.54056 Å)
R_{p} [%]	4.4	R_{wp} [%]	6.8
R_{exp} [%]	5.5	S	1.2

$$R_{\text{p}} = 100 \sum |y_{\text{obs}} - y_{\text{calc}}| / \sum |y_{\text{obs}}|, \quad S = [R_{\text{wp}}/R_{\text{exp}}],$$

$$R_{\text{exp}} = 100 [(N - P + C) / \sum_{\text{w}} (y_{\text{obs}}^2)]^{1/2}, \quad N - P + C \text{ is the number of degrees of freedom,}$$

$$R_{\text{wp}} = 100 [\sum_{\text{w}} |y_{\text{obs}} - y_{\text{calc}}|^2 / \sum_{\text{w}} |y_{\text{obs}}|^2]^{1/2}$$

The evolution of the unit cell parameters and unit-cell volume for the sulphide Cu₃-M-S₄ family as function of choice M element (x) is shown in Fig. 3a. Figure 3b illustrates the variation of the bond distances for the same family. It should be noted that related tendencies are

observed in all compounds of the system Cu₃-M-VI₄, sulphides, selenides and tellurides.

Concerning to the solid solution formation, Table V shows the experimental unit-cell parameters reported for the Cu₃TaS_{4-x}Se_x system, and Fig. 4 shows that unit-

TABLE III

Unit cell, atomic coordinates, isotropic temperature factors, bond distances [\AA] and angles [$^\circ$] for Cu_3TaS_4 , derived from the Rietveld refinement.

Atom	Ox.	Site	x	Y	z	foc	B [\AA^2]
Cu	+1	3d	1/2	0	0	1	1.2(5)
Ta	+5	1a	0	0	0	1	1.2(5)
S	-2	4d	0.2475(5)	0.2475(5)	0.2475(5)	1	1.2(5)
		Cu-S	2.380(3) \AA	Ta-S	2.364(3) \AA		
S-Cu-S ⁽ⁱ⁾		108.4(1)	S-Cu-S ⁽ⁱⁱ⁾	110.0(1)	S-Cu-S ⁽ⁱⁱⁱ⁾	110.0(1)	
S ⁽ⁱ⁾ -Cu-S ⁽ⁱⁱ⁾		110.0(1)	S ⁽ⁱ⁾ -Cu-S ⁽ⁱⁱⁱ⁾	109.3(1)	S ⁽ⁱⁱ⁾ -Cu-S ⁽ⁱⁱⁱ⁾	108.4(1)	
S ^(iv) -Ta-S ^(v)		109.5(1)	S ^(iv) -Ta-S ⁽ⁱ⁾	109.5(1)	S ^(iv) -Ta-S	109.5(1)	
S ^(v) -Ta-S ⁽ⁱ⁾		109.5(1)	S ^(v) -Ta-S	109.5(1)	S ⁽ⁱ⁾ -Ta-S	109.5(1)	

Symmetry codes: (i) $y, -x, -z$; (ii) $1-x, -y, z$; (iii) $1-y, x, -z$; (iv) $-y, x, -z$; (v) $-x, -y, z$

TABLE IV

Comparative table of the $\text{Cu}_3\text{-M-VI}_4$ ($M = \text{V, Nb, Ta, VI} = \text{S, Se, Te}$) sulvanite compounds ([*] = this work).

	a [\AA]	V [\AA^3]	Cu-VI [\AA]	M-VI [\AA]	Ref.
Cu_3VS_4	5.393(1)	156.85(5)	2.299(1)	2.219(1)	9
Cu_3NbS_4	5.5001(6)	166.38(3)	2.359(1)	2.311(1)	10
Cu_3TaS_4	5.5145(1)	167.70(1)	2.380(3)	2.364(3)	[*]
Cu_3VSe_4	5.5636(5)	172.21(3)	2.392(1)	2.357(1)	11
Cu_3NbSe_4	5.638(1)	179.22(6)	2.442(1)	2.443(1)	12
Cu_3TaSe_4	5.6600(1)	181.32(1)	2.454(3)	2.461(3)	13
Cu_3VTe_4	—	—	—	—	—
Cu_3NbTe_4	5.9217(1)	205.65(1)	2.588(4)	2.633(4)	14
Cu_3TaTe_4	5.930(2)	208.5(1)	2.596(1)	2.650(1)	15

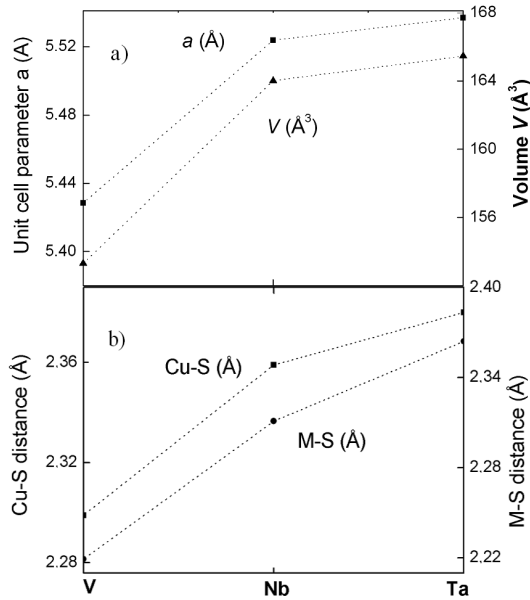


Fig. 3. Bond distances Cu-S and M-S as function of the Mn cation (V, Nb, Ta). The dotted lines represent a linear fit. (a) Unit cell parameter a (\AA) and cell volume (\AA^3), and (b) bond distances Cu-S (\AA) and M-S (\AA), as function of the M cation (V, Nb, Ta) for the sulfide Cu_3MS_4 system.

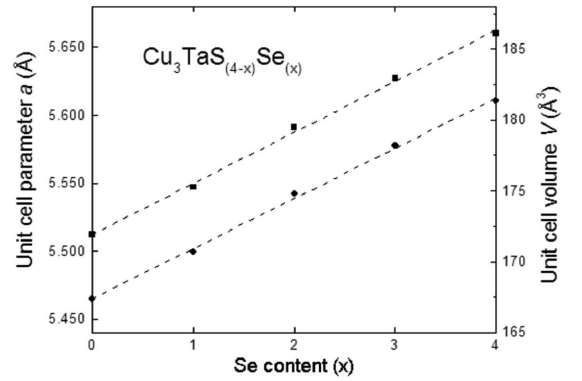


Fig. 4. Unit cell parameter a (\AA) and cell volume (\AA^3) for the $\text{Cu}_3\text{TaS}_{4-x}\text{Se}_x$ system. The dotted lines represent a linear fit.

-cell parameters and unit-cell volume increase linearly with increasing Se content which suggests for this system a solid solution formation in all range of compositions. Since all the compounds of the system $\text{Cu}_3\text{-M-VI}_4$ are isostructural, solid solutions in all combinations are expected.

TABLE V

Unit cell parameters vs. composition for the system $\text{Cu}_3\text{TaS}_{4-x}\text{Se}_x$ system ([*] = this work).

		a [Å]	V [Å ³]	Ref.
$x = 0$	Cu_3TaS_4	5.5145(1)	167.70 (1)	[*]
$x = 1$	$\text{Cu}_3\text{TaS}_3\text{Se}$	5.547	170.7	4
$x = 2$	$\text{Cu}_3\text{TaS}_2\text{Se}_2$	5.591	174.8	4
$x = 3$	$\text{Cu}_3\text{TaSSe}_3$	5.627	178.2	4
$x = 4$	Cu_3TaSe_4	5.6600(1)	181.32 (1)	13

4. Conclusions

The crystal structure of the ternary Cu_3TaS_4 was refined by the Rietveld method using X-ray powder diffraction data. This compound is isostructural with the mineral sylvanite. For the complete system $\text{Cu}_3\text{-M-VI}_4$ with $\text{M} = \text{V}, \text{Nb}, \text{Ta}$ and $\text{VI} = \text{S}, \text{Se}, \text{Te}$, solid solutions are expected.

Acknowledgments

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